

U.S. PAT. & TM. OFF. 10/01/2001

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10071207	FILING DATE 02/11/2002	CLASS T38 257	SUBCLASS Z11	GAU 2811	EXAMINER GUERRERO
----------------------	---------------------------	---------------------	-----------------	-------------	----------------------

**APPLICANTS: Kluth George; Xiang Qi; 2822

OK MG
**CONTINUING DATA VERIFIED:
THIS APPLN CLAIMS BENEFIT OF 60/267,407 02/09/2001

BEST AVAILABLE COPY

NONE MG
** FOREIGN APPLICATIONS VERIFIED:

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	ATTORNEY DOCKET NO	
35 USC 119 conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	52352-785	
Verified and Acknowledged Examiners's initials MG		
TITLE : Method of manufacturing a semiconductor device with supersaturated source/drain extensions and metal silicide contacts		

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
Assistant Examiner		DRAWING	
ISSUE FEE		Sheets Drwg.	Figs. Drwg.
Amount Due	Date Paid	Print Fig.	
Primary Examiner		Application Examiner	
PREPARED FOR ISSUE			
WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.			

☐ TERMINAL
DISCLAIMER

FILED WITH: ☐ DISK (CRF) ☐ CD-ROM
(Attached in pocket on right inside flap)